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PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of

Attn: OIPE

Kiyoshi UCHIDA et al.

Group Art Unit:

Application No.: 10/544,099

Docket No.: 124895

Filed: August 2, 2005

For: MAGNETIC GARNET SINGLE CRYSTAL FILM FORMATION SUBSTRATE,
THE PRODUCTION METHOD, OPTICAL ELEMENT AND THE PRODUCTION
METHOD

REQUEST FOR CORRECTION OF PALM RECORDS

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

Attached is a photocopy of the original filing receipt on which errors have been corrected in red. These errors are being brought to the attention of the Patent and Trademark Office so that it may correct its records.

Respectfully submitted,

James A. Oliff
Registration No. 27,075

Linda M. Saltiel
Registration No. 51,122

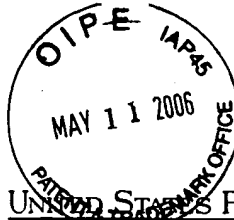
JAO:LMS/hjr

Date: May 11, 2006

OLIFF & BERRIDGE, PLC
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Alexandria, Virginia 22320
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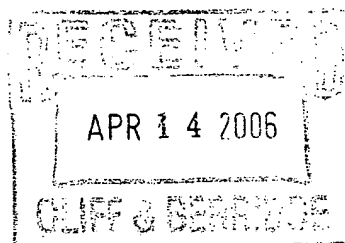
UNITED STATES PATENT AND TRADEMARK OFFICE

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APPL NO.	FILING OR 371 (c) DATE	ART UNIT	FIL FEE REC'D	ATTY. DOCKET NO	DRAWINGS	TOT CLMS	IND CLMS
10/544,099	08/02/2005	1722	900	124895	7	20	2 X

CONFIRMATION NO. 9455

25944
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FILING RECEIPT



OC0000000184 76085

Date Mailed: 04/10/2006

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Applicant(s)

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Correction Also.
 on Page 2 →

Power of Attorney: The patent practitioners associated with Customer Number 25944.

Domestic Priority data as claimed by applicant

This application is a 371 of PCT/JP04/00760 01/28/2004

Foreign Applications

JAPAN 2003-027165 ~~04/02/2003~~

02/04/2003

If Required, Foreign Filing License Granted: 04/06/2006

The country code and number of your priority application, to be used for filing abroad under the Paris Convention, is **US10/544,099**

Projected Publication Date: 07/13/2006

Non-Publication Request: No

Early Publication Request: No

Title

~~Substrate for forming magnetic garnet single-crystal film, process for producing the same, optical device and process for producing the same~~

Preliminary Class

117

magnetic garnet single crystal film
formation substrate, the production
method, optical element and the

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Production method

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Title 37, Code of Federal Regulations, 5.11 & 5.15

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